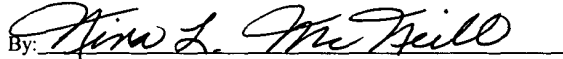


"Express Mail" Label No. EV326934290US
Date of Deposit September 8, 2003

I hereby certify that this is being deposited with the United States Postal Service "Express Mail Post Office to Address" service under 37 CFR 1.10 on the date indicated above and is addressed to:

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

By: 

PATENT
Attorney Docket No. A4356/T035310
AMAT No. 4356
USA/D01/DSM/HDP/CVD/JW
TTC No. 016301-035310US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Tetsuya Ishikawa *et al.*

Application No.: Not yet assigned

Filed: Not yet assigned

For: METHOD OF REDUCING
PLASMA CHARGE DAMAGE FOR
PLASMA PROCESSES

Examiner: Not yet assigned

Technology Center/Art Unit: Not yet
assigned

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please enter the following amendments and remarks:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.